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Appl. No. 10/603,361 Reply to Office Action of 12/30/2005

Amdt. dated 03/23/2006

Attorney Docket No.: N1085-00089

TSMC 2002-0917

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bor-Wen Chan, et al.

Examiner: Ron Everett Pompey

Serial No.: 10/603,361

Group Art Unit: 2812

Filed: 06/25/2003

Confirmation No.: 2523

For: METHOD OF MAKING A MULTIPLE GATE ELECTRODE ON A

SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING/FACSIMILE PURSUANT TO 37 C.F.R. §1.8

I hereby certify that this document (and any documents referred to therein) are being sent by facsimile to (571) 273-8300 addressed to the following:

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P. O. Box 1450
Alexandria, VA 22313-1450

Date: March 23, 2006

Maria E. Provencio

Examiner Ron Everett Pompey Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO OFFICE ACTION DATED DECEMBER 30, 2005

## **EXPEDITED PROCEDURE UNDER 37 CFR 1.116**

Sir:

Responsive to the final Office Action dated December 30, 2005, please reexamine and reconsider the above-identified patent application according to the amendments and remarks provided.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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